

PTO/SB/08a
(08-03)

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>		Complete if Known	
		Application Number	10/562,869
		Filing Date	Dec. 28, 2005
		First Named Inventor	Wolfram Glauert
		Group Art Unit	Not assigned 2814
		Examiner Name	Not assigned Eva Montalvo
Sheet 1	2	Attorney Docket Number 411000-144	

U.S. PATENT DOCUMENTS					
Examiner Initial*	Cite No. ¹	Document Number Number-Kid Code ² (if known)	Publication- Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	103	US-6,852,583	10/09/2003	Adolf Bernds et al.	See accompanying Disclosure Statement filed herewith
	102	US-6,903,958	03/21/2002	Adolf Bernds et al.	
	133	US-10/344,926	02/12/2004	Adolf Bernds et al.	
	99	US-10/344,951	02/12/2004	Adolf Bernds et al.	
	110	US-10/362,932	10/02/2003	Adolf Bernds et al.	
	106	US-10/380,113	09/25/2003	Adolf Bernds et al.	
	105	US-10/381,032	02/12/2004	Adolf Bernds et al.	
	108	US-10/433,959	04/01/2004	Adolf Bernds	
	111	US-10/433,961	04/01/2004	Wolfgang Clemens et al.	
	109	US-10/451,108	05/13/2004	Mark Giles et al.	
	104	US-10/467,636	11/04/2004	Adolf Bernds et al.	
	113	US-10/473,050	05/20/2004	Adolf Bernds et al.	
	101	US-10/479,234	12/30/2004	Adolf Bernds et al.	
	100	US-10/479,238	10/20/2004	Adolf Bernds et al.	
	115	US-10/492,922	03/03/2005	Erwann Bullet et al.	
	114	US-10/492,923	12/23/2004	Wolfgang Clemens et al.	
	119	US-10/498,610	N/A	Walter Fix et al.	
	120	US-10/508,640	N/A	Walter Fix et al.	
	121	US-10/508,737	N/A	Adolf Bernds et al.	
	122	US-10/517,750	N/A	Wolfgang Clemens et al.	
	123	US-10/523,216	N/A	Adolf Bernds et al.	
	124	US-10/523,487	N/A	Wolfgang Clemens et al.	
	127	US-10/524,646	N/A	Walter Fix et al.	
	128	US-10/533,756	N/A	Wolfgang Clemens et al.	

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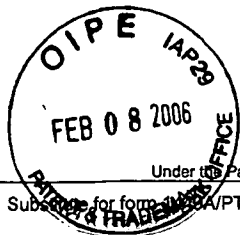
Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Complete if Known	
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				First Named Inventor	Wolfram Glauert
				Group Art Unit	Not assigned 2814
				Examiner Name	Not assigned Eva Montalvo
Sheet	2		2	Attorney Docket Number	411000-144

	129	US-10/534,678	N/A	Wolfgang Clemens et al.	
	131	10/535,448	N/A	W. Clemens et al.	
	132	10/535,449	N/A	Walter Fix et al.	
	136	US-10/541,815	N/A	Axel Gerlt et al.	
	137	US-10/541,956	N/A	Wolfgang Clemens et al.	
	138	US10/541,957	N/A	Walter Fix et al.	
	139	US-10/543,561	N/A	Wolfgang Clemens et al.	
	140	US-10/542,678	N/A	Adolf Bernds et al.	
	141	US-10/542,679	N/A	Adolf Bernds et al.	
	143	US-10/562,989	N/A	Jurgen Ficker et al.	
	144	US-10/562,869	N/A	Wolfram Glauert et al.	
Examiner Signature		/Eva Montalvo/		Date Considered	05/12/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

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Substitute for form PTO/AIA/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

Sheet	1	Of	11	Application Number	10/562,869
				Filing Date	Dec. 28, 2005
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U.S. PATENT DOCUMENTS

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		US-2002/0022284	02-21-2002	Heeger	See attached statement for relevancy
		US-2002/0053320	05-09-2002	Duthaler	
		US-2002/0056839	05-16-2002	Joo et al.	
		US-2002/0068392	06-06-2002	Lee et al.	
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		US-2002/0018911	02-00-2002	Bemius et al.	
		US-2002/0195644	12-26-2002	Dodabalapur et al.	
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		US-2004/0013982	01-00-2004	Jacobson et al.	
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Duplicate		US-3,769,096	10-30-1973	Ashkin	
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Sheet	2		11	Attorney Docket Number	411000-144

		US-5,321,240	06-14-1994	Takihira	
		US-5,347,144	09-13-1994	Garnier et al.	
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		US-5,574,291	11-12-1996	Dodabalapur et al.	
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		US-5,629,530	05-13-1997	Brown et al.	
		US-5,652,645	07-29-1997	Jain	
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		US-5,729,428	03-17-1998	Sakata et al.	
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		US-5,869,972	02-09-1999	Birch et al.	
		US-5,892,244	04-06-1999	Tanaka et al.	
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		US-6,133,835	10-17-2000	DeLeeuw et al.	
		US-6,207,472	03-27-2001	Calligari et al.	
		US-6,215,130	04-00-2001	Dodabalapur	
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		US-6,284,562	09-00-2001	Batlogg et al.	
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Sheet	3		11	Attorney Docket Number	411000-144

		US-6,429,450	08-06-2002	Mutsaers et al. et al.	
		US-6,517,955	02-00-2005	Jacobsen et al.	
		US-6,852,583	02-08-2005	Bernds et al.	
		US-6,903,958	06-07-2005	Bernds et al.	
		US-6,960,489	11-01-05	Bernds et al.	

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Examiner Initial*	Cite No. ¹	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (if known)	Publication- Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		DE 33 38 597	05-02-1985	GAO Gesellschaft	See attached statement for relevancy of all foreign language documents	
		DE 100 06 257 (title page only)	09-14-2000	IBM		
		DE 100 12 204 (title page only)	09-20-2001	Siemens		
		DE 100 33 112 (title page only)	01-24-2002	Siemens		
		DE 100 43 204 (title page only)	04-04-2002	Siemens		
		DE 100 45 192	04-04-2002	Siemens AG		
		DE 100 47 171	04-18-2002	Siemens AG		
		DE 100 58 559	05-29-2002	Interactive Biotech.		
		DE 100 61 297 (title page only)	06-27-2002	Siemens		
		DE 101 17 663	10-17-2002	Samsung SDI Co.		
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		DE 102 19 905	12-04-2003	Osram Opto Semicond.		
		DE 198 16 860	11-18-1999	Deutsche Telekom		
		DE 198 52 312 (title page only)	05-20-1999	Nintendo Co.		
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		DE 199 21 024 (title page only)	11-16-2000	Eichmann		
		DE 199 33 757	01-25-2001	Giesecke & Devrient		
		DE 199 35 527	02-08-2001	Giesecke & Devrient		
		DE 199 37 262	03-01-2001	Siemens		

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Sheet	4		11	Attorney Docket Number	411000-144

	DE 424 38 32	06-30-1994	Daimler-Benz		
	DE 695 19 782 (title page only)	01-03-2001	News Datacom Ltd.		
	EP 0 128 529	12-19-1984	BASF		
	EP 0 268 370 A2	05-25-1988	Canon Kabushiki Kaisha		X
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	EP 0 350 179	01-10-1990	W & T Avery Ltd.		X
	EP 0 442 123	08-21-1991	Neste OY		X
	EP 0 460 242	12-11-1991	Nippon Petrochemicals		X
	EP 0 501 456 A2	09-02-1992	Sony		X
	EP 0 501 456 A3	09-02-1992	Sony		X
	EP 0 511 807	11-04-1992	GEC Avery Ltd.		X
	EP 0 528 662	02-24-1993	Kabushiki Kaisha Toshiba		X
	EP 0 615 256	09-23-1998	Koninklijke Philips		
	EP 0 685 985	12-06-1995	Hitachi Metals		X
	EP 0 716 458	06-12-1996	AT&T Corp.		X
	EP 0 785 578 A2	07-23-1997	AT & T Corp.		X
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	EP 0 962 984	12-08-1999	Lucent Technologies		X
	EP 0 966 182	12-22-1999	LG Electronics		X
	EP 0 979 715	02-16-2000	Adolf Illig Maschinenbau		
	EP 0 981 165	02-23-2000	Lucent Technologies		X
	EP 0 989 614 A2	03-29-2000	Sel Semiconductor		X
	EP 1 048 912	11-02-2000	Miele & Cie		
	EP 1 052 594	11-15-2000	Sokymat S.A.		
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	EP 1 102 335 A2	05-23-2001	Lucent Technologies		X
	EP 1 103 916 (title page only)	05-30-2001	Infinsion Technologies		
	EP 1 104 035 A2	05-30-2001	Lucent Technologies		X
	EP 1 134 694	09-19-2001	Infineon Technologies		
	EP 1 224 999 (title page only)	07-24-2002	Sumitomo Heavy Ind.		X
	EP 1 237 207	09-04-2002	Fuji Photo Film Co.		X
	EP 1 318 084	06-11-2003	Nippon Sanso Corp.		
	FR2793089	11-03-2000	Liger Rene		

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Sheet	5		11	Attorney Docket Number	411000-144

		GB 2 058 462	04-08-1981	Shin-Etsu Polymer Co.		X
		GB 723,598	02-09-1955	N V Phillips Gloeilampenfabrieken		X
		GR2001P03239 (not available)				
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		JP 01169942 (abstract)	07-05-1989	Hitachi Ltd.		X
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		JP 05259434	10-05-1993	Nisha Printing		X
		JP 05347422 (abstract)	12-27-1993	Fujitsu Ltd.		X
		JP 08197788 (abstract)	08-06-1995	Hitachi Koki		X
		JP 09083040 (abstract)	03-28-1997	Sharp Corp.		X
		JP 09320760 (abstract)	12-12-1997	Matsushita Electric Ind.		X
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		JP 10026934 (abstract)	01-27-1998	Toshiba Chem. Corp.		X
		JP 2001085272 (abstract)	03-30-2001	Matsushita Electric Ind.		X
		JP 2969184	12-20-1991	_____		
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Duplicate		JP 54069392 (abstract)	06-04-1979	Sakamoto Mitsuru		X
		JP 54069392 (abstract)	06-04-1979	NEC Corp.		X
		JP 60117769 (abstract)	06-25-1985	Fujitsu Ltd.		
		JP 61001060 (abstract)	01-07-1986	Hitachi Koki		X
		JP 61167854	07-29-1986	Murata Mfg. Co. Ltd.		X
		WO 00/33063	06-08-2000	Moorlodge Biotech		X
		WO 00/36666	06-22-2000	E Ink Corp.		X
		WO 00/79617	12-28-2000	Cambridge University		X
		WO 01/03126	01-11-2001	Regents of U. of CA		X
		WO 01/06442	01-25-2001	Yip		X
		WO 01/08241	02-01-2001	E Ink Corporation		X
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		WO 01/46987	06-28-2001	Plastic Logic Ltd.		
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	WO 01/47045	06-28-2001	Plastic Logic		X
	WO 02/05360	01-17-2002	Siemens AK		X
	WO 02/05361	01-17-2002	3M Innovative Prop.		X
	WO 02/065557 A1	08-22-2002	Siemens		
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	WO 02/071139	09-12-2002	Acree AB		X
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	WO 02/076924	10-03-2002	Nissinbo Industries		
	WO 02/091495	11-14-2002	Coatue Corp.		X
	WO 02/095805 A2	11-28-2002	Plastic Logic Limited		X
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	WO 02/099907	12-12-2002	Siemens		X
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	WO 02/15264	02-21-2002	Siemens AK		
	WO 02/19443	03-07-2002	Siemens		
	WO 02/19443 (abstract)	03-07-2002	Siemens		X
	WO 02/29912	04-11-2002	Cambridge University		X
	WO 02/43071	05-30-2002	Thin Film Electronics		X
	WO 02/47183	06-13-2002	Siemens		
	WO 02/47183 (abstract)	06-13-2002	Siemens		X
	WO 03/046922	06-05-2003	Infineon Technologies		
	WO 03/067680	08-14-2003	Canon Kabushiki Kaisha		X
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	WO 03/095175	11-20-2003	ZBD Displays Ltd.		
	WO 04/042837 A2 abstract	05-21-2004	Siemens		X
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	WO 04/047144 A2 (abstract)	06-03-2004	Siemens		X
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	WO 04/047144 A3 (abstract)	06-03-2004	Siemens		X
	WO 04/7194 A2	06-03-2004	Siemens		X
	WO 04/7194 A2 (abstract)	06-03-2004	Siemens		X
	WO 04/7194 A3	06-03-2004	Siemens		X
	WO 2004/032257	04-15-2004	Leonhard Kurz GmbH		

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		WO 2004/083859	09-30-2004	Platform Diagnostics		
		WO 93/16491	08-19-1993	Kopin Corp.		X
		WO 94/17556	08-04-1994	FCI-Fiberchem		X
		WO 95/06240	03-02-1995	Metrika Laboratories		X
		WO 95/31831 (title page only)	11-23-1995	Philips Electronics		X
		WO 96/02924	02-01-1996	Oryx Techn Corp.		X
		WO 96/19792	06-27-1996	Trustees of Princeton		X
		WO 97/12349	04-03-1997	DeRivaz		X
		WO 97/18944	05-29-1997	Gov't of USA		X
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		WO 98/18156 (abstract)	04-30-1998	Steag Microtech		X
		WO 98/18186 (title page only)	04-30-1998	Erico Lightning		X
		WO 98/40930	09-17-1998	Precision Dynamics		X
		WO 99/07189	02-11-1999	Cambridge		X
		WO 99/10929 (title page only)	03-04-1999	Koninklijke Philips		X
		WO 99/10939	03-04-1999	Koninklijke Philips		X
		WO 99/21233	04-29-1999	Regents of U California		X
		WO 99/40631	08-12-1999	Opticom USA		X
		WO 99/53371	10-21-1999	E Ink Corp.		X
		WO 99/54936	10-28-1999	Cambridge Display		X
		WO 99/54936 Corrected Version	10-28-1999	Cambridge Display		
		WO 99/66540	12-23-1999	Opticom ASA		X

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				First Named Inventor	Wolfram Glauret
				Group Art Unit	Not Assigned 2814
				Examiner Name	Not Assigned Eva Montalvo
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